

Notice of References Cited	Application/Control No. 10/761,724	Applicant(s)/Patent Under Reexamination HSIEH, CHIA-MING	
	Examiner Dameon E Levi	Art Unit 2841	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,355,016	10-1994	Swirbel et al.	257/659
*	B	US-6,472,724	10-2002	Matsuzawa et al.	257/659
*	C	US-5,838,551	11-1998	Chan, Yee-Ning	361/818
*	D	US-5,400,949	03-1995	Hirvonen et al.	228/180.22
*	E	US-5,886,876	03-1999	Yamaguchi, Tadashi	361/767
*	F	US-5,694,300	12-1997	Mattei et al.	361/818
*	G	US-6,362,516	03-2002	Waters, Ronald S.	257/678
*	H	US-6,826,053	11-2004	Kato et al.	361/715
*	I	US-5,548,084	08-1996	Tracy, James L.	174/35R
*	J	US-6,297,967	10-2001	Davidson et al.	361/800
*	K	US-6,882,040	04-2005	Hosoya, Futoshi	257/699
*	L	US-6,881,896	04-2005	Ebihara, Masami	174/35GC
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.